

Search Notes 	Application/Control No.	Applicant(s)/Patent under Reexamination	
	09/752,046	SCHIER, JOHN ELMORE	
	Examiner	Art Unit	
	Christopher A. Revak	2131	

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
713	200-202	11/23/2004	CR
709	204,206	11/23/2004	CR
705	50,56	11/23/2004	CR
713/150,168,175,176		11/23/2004	CR